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PATENT

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : T.L. Ritzdorf, et al.  
Application No. : 09/018,783 Confirmation No.: 1242  
Filed : 4 February 1998  
For : METHOD AND APPARATUS FOR LOW TEMPERATURE  
ANNEALING OF METALLIZATION MICRO-STRUCTURES IN  
THE PRODUCTION OF A MICROELECTRONIC DEVICE

Examiner : D.M. Collins  
Art Unit : 2823  
Docket No. : 29195.8162US  
Date : October 1, 2001

Commissioner for Patents  
Washington, DC 20231

AMENDMENT

FAX COPY RECEIVED  
OCT 25 2001  
TECHNOLOGY CENTER 2800

Dear Commissioner:

The present Amendment amends both the specification and the claims in the present application. In accordance with 37 C.F.R. § 1.121, enclosed herewith is an Appendix which has been marked to show the changes made by amendment.

IN THE SPECIFICATION:

Please amend the paragraph appearing at page 12, lines 15-22 to read as follows: